

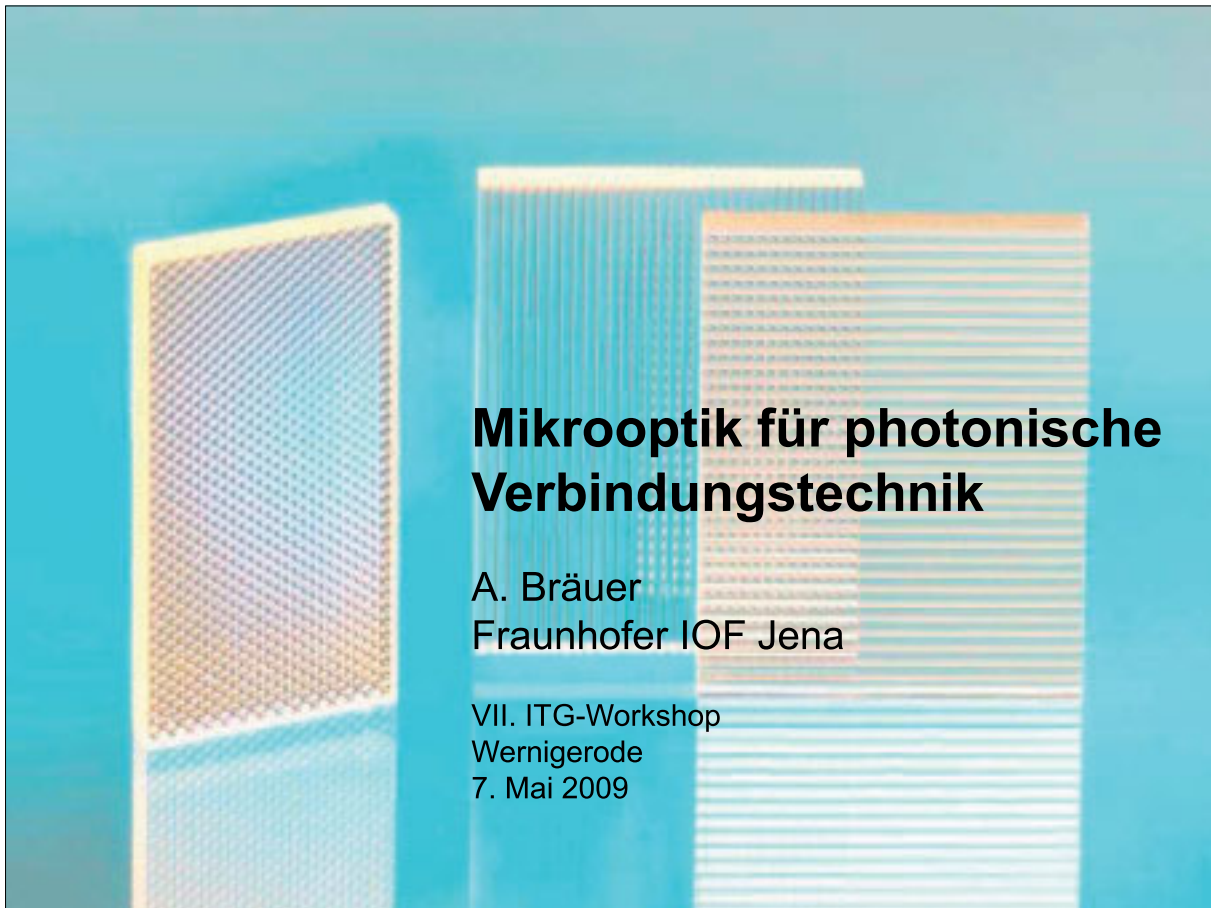


Ulrich H. P. Fischer-Hirchert (Herausgeber)  
**VII. ITG-Workshop Photonische Aufbau- und  
Verbindungstechnik**



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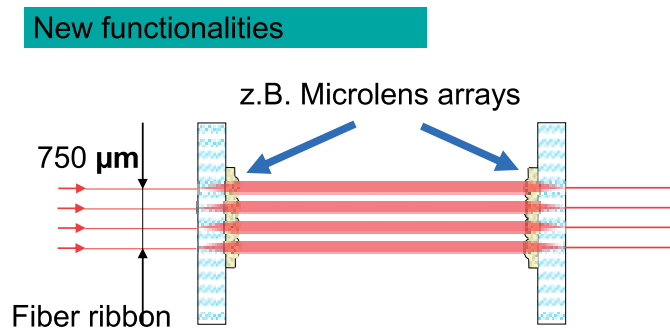
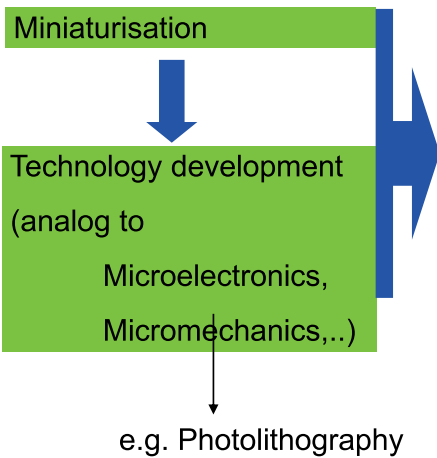
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Tailored Light - Licht nach Maß

### Definition of Microoptics ?

- „...efficient exploitation of light opening up new applications for optics ...“ (Fa. Heptagon)
- „enabling technology using microelectrical equipment“
- NOT ONLY ‚miniaturised, low-cost optics‘, BUT:



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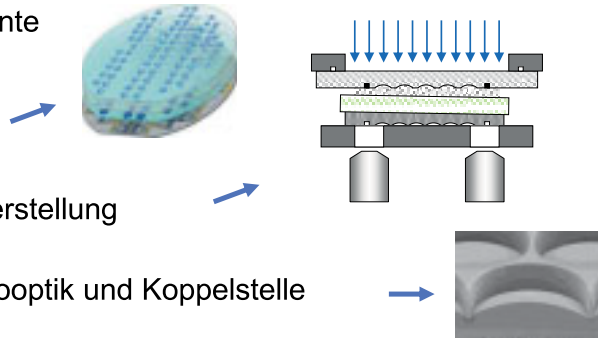
## “Mikrooptik für photonische Verbindungstechnik”

Wesentliche Rahmenbedingungen sind (Zitat Klaus Schulz):

- Kosten
- Baugröße
- Energie
- Packungsdichte
- Funktionsdichte

Wie können mikrooptische Bauelemente dem am besten Rechnung tragen ?

- Wafer-level Optik-Technologie
- UV-Replikationstechnologie zur Herstellung
- Gleichzeitige Herstellung von Mikrooptik und Koppelstelle



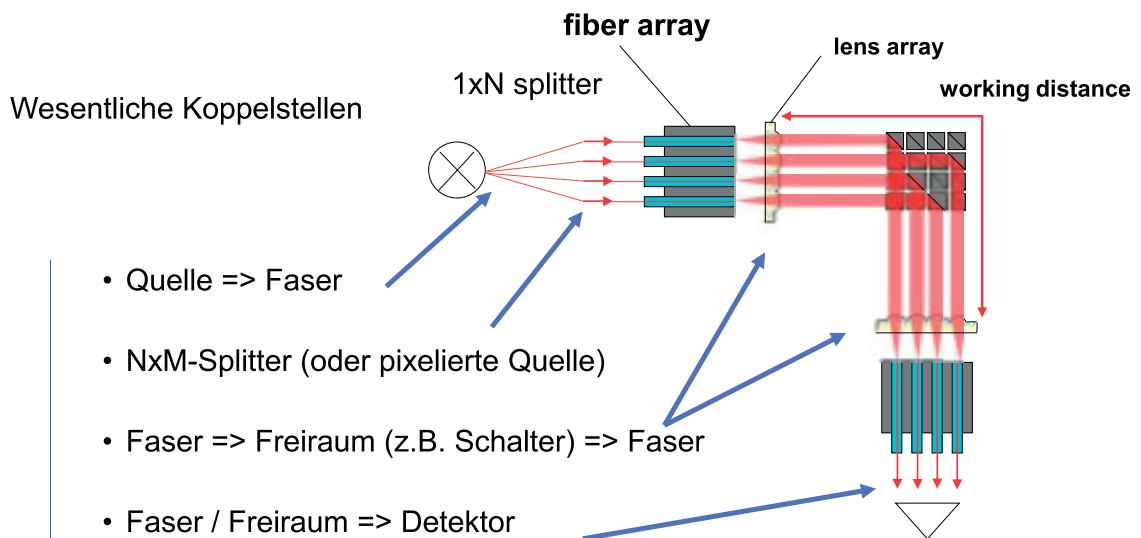
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## Mikrooptik für photonische Verbindungstechnik



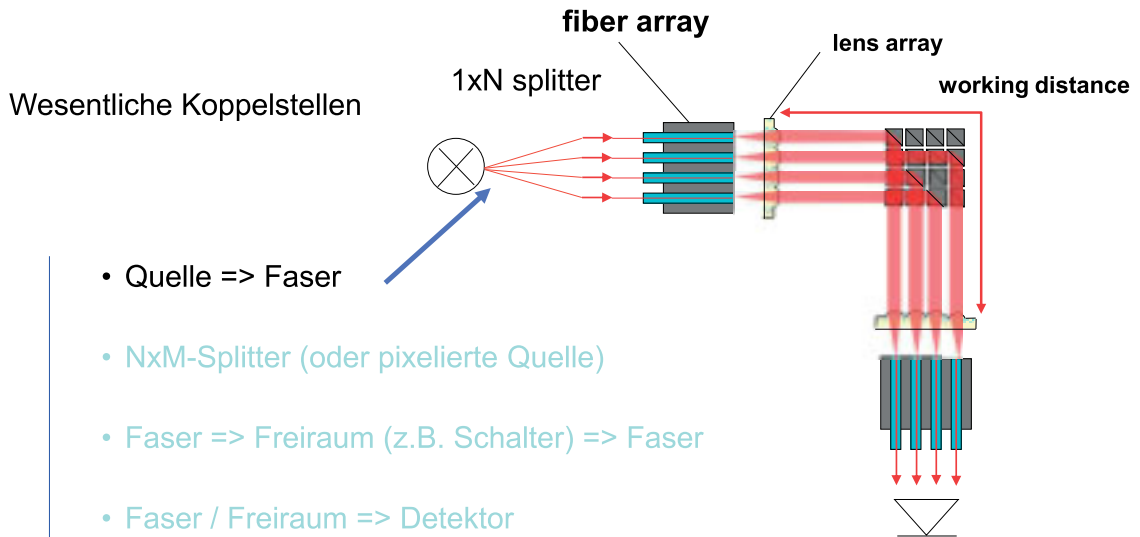
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## Mikrooptik für photonische Verbindungstechnik



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## Etch-emitting Laser => Fiber coupling

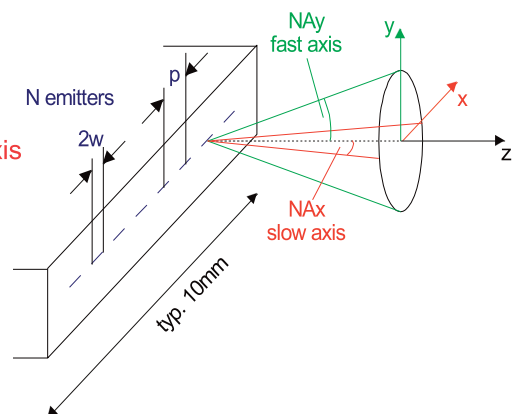
Requirements for Laserdiode to-fiber-coupling:

Beam parameter product  $w_0 \cdot NA = M^2 \lambda / \pi$

Single emitter (typ.):

$M_y^2 < 1.5$  fast axis  
 $M_x^2 \approx 15...50$  slow axis

Fiber 100/200 $\mu\text{m}$  0.22NA  $M_x^2 \approx 43 / 86$



Efficient coupling for  $M_{\text{laser}} < M_{\text{fiber}}$

>> Main problem: Slow axis beam quality

>> Solution: Optical rearrangement of emitters – several principles

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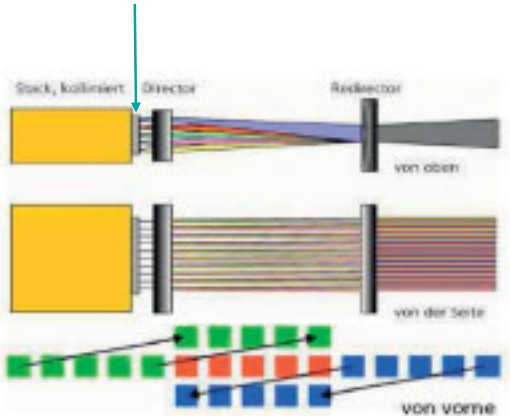
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## Laser => Fiber coupling: Skew ray imaging coupler

Principle

FAC 'inclined' (,fast axis collimation')

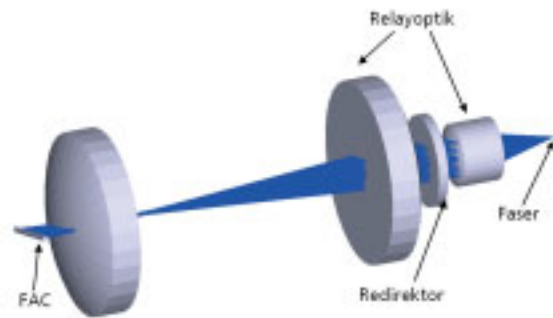


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Design

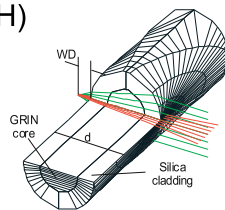


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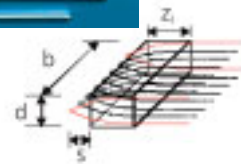
## Laser => Fiber coupling - Micro-optical components

1. Fast axis collimation: High-NA cylindrical lens **with large field: GRIN lenses** (DORIC, GRINTECH)

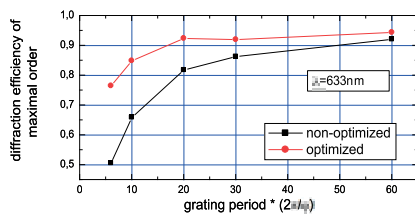
DORIC



GRINTECH



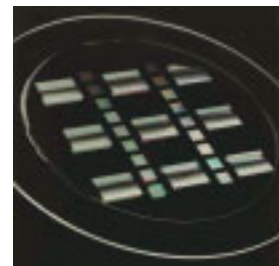
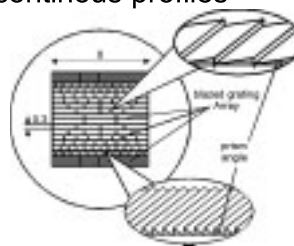
2. Redirector: Blazed grating array  
- Replication of direct laser-written continuous profiles



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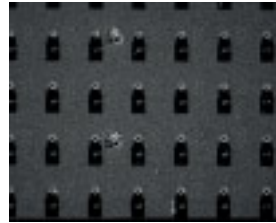
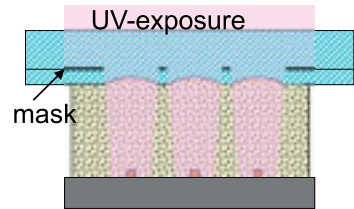
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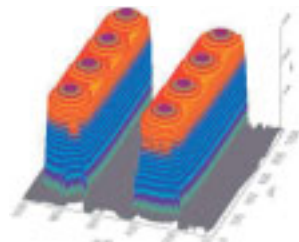


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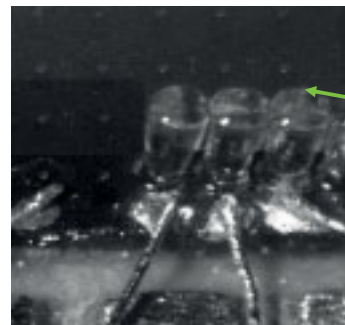
### VCSEL-collimation optics on wafer scale



VCSEL array, x-pitch = 250µm



surface profile  
Ø250µm lenses  
polymer pedestals



row of  
microlenses  
pitch 250µm

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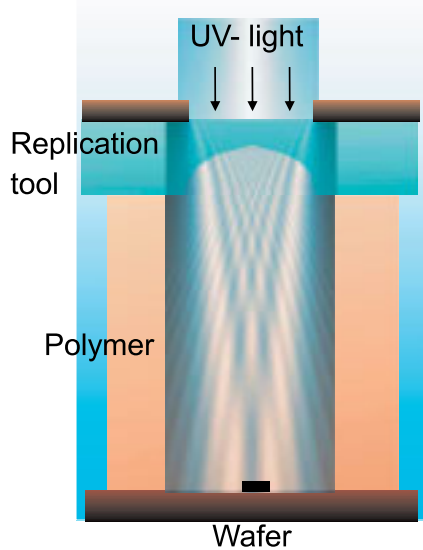
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### VCSEL-collimation optics on wafer scale

Combination of replication and selective photopolymerisation



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### VCSEL-collimation on wafer scale

Selective UV- Replication !



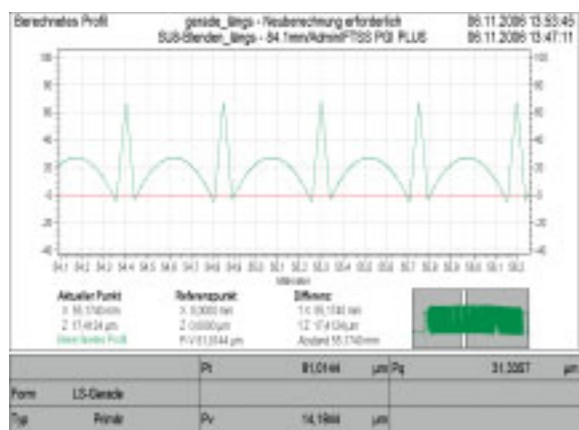
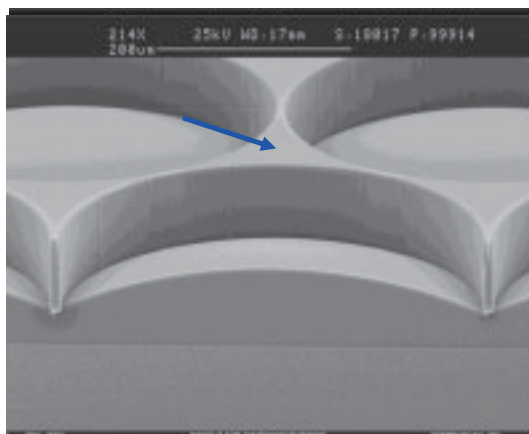
Material: ORMOCER

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### Collimation optics and holding structure (wafer scale)



Material: ORMOCER / SU-8

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